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Date Signature

11/28/00
8/Response



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Reid A. BRENNEN et al.

Group Art Unit: 1756

Serial No.: 09/233,694

Examiner: C. Young

Filing Date: January 19, 1999

Title: METHOD FOR PRODUCING HIGH-SURFACE AREA TEXTURING OF A SUBSTRATE, SUBSTRATES PREPARED THEREBY AND MASKS FOR USE THEREIN

RESPONSE TO FINAL REJECTION
EXPEDITED PROCEDURE - EXAMINING GROUP 1756

Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

This is in response to an Office Action on the merits concerning the patent application identified above, mailed from the PTO on September 22, 2000. Reconsideration of the application in view of remarks is respectfully requested.

REMARKS

INTRODUCTORY COMMENTS:

Claims 23-27, 29-46, 48-50, 52-69, 77 and 78 are currently pending. In a previous Office Action, all pending claims were rejected under 35 U.S.C. §102(b) as anticipated by or, in the alternative, under 35 U.S.C. § 103(a) as obvious over either one of U.S. Patent Nos. 5,571,410 to